Resonant Microsensors

University Enterprise Training Partnership project

Thomas Fabula, Hans-Joachim Wagner

Institute of Microstructure and Information Technology (IMIT), Villingen-Schwenningen, Germany

Albert Prak

MESA Research Intitute, University of Twente, Enschede, the Netherlands

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https://tfconsult.com/comett-course-resonant-microsensors/